Electronic Patent Application Fee Transmittal							
Application Number:	08893917						
Filing Date:	11-Jul-1997						
Title of Invention:	REMOTE PLASMA CLEANING SOURCE HAVING REDUCED REACTIVITY WITH A SUBSTRATE PROCESSING CHAMBER						
First Named Inventor/Applicant Name:	KARL A. LITTAU						
Filer:	William Leland Shaffer/Kristina Alvarez						
Attorney Docket Number:	A2119/T21300						
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